

17264 U.S. PTO
06/25/03

Inventors: Tingkai Li, Sheng Teng Hsu, David R. Evans
and Bruce D. Ulrich

Title: MOCVD SELECTIVE DEPOSITION OF C-AXIS ORIENTED
Pb₅Ge₃O₁₁ THIN FILMS ON HIGH-k GATE OXIDES

No. of pages in Specification: 13 No. of Claims: 12

No. of sheets of Drawings: 2 Formal: , Informal: X

Also enclosed are:

- X A Declaration.
- X An Assignment and Recordation Form Cover Sheet.
- X Power of Attorney by Assignee.
- A certified copy of a priority application.
- A Verified Statement to establish small entity status.
- X An Information Disclosure Statement under 37 C.F.R. §1.56.

The filing fee pursuant to 37 C.F.R. §1.16 is determined as follows:

No. Filed	No. Extra		Rate Small Entity/ Other Than Small Entity	
Basic Fee			\$375.00 \$750.00	= \$ 750.00
Total Claims <u>12</u> - 20	<u>0</u>	X	\$ 9.00 \$18.00	\$ 000.00
Independent Claims <u>2</u> - 3	<u>0</u>	X	\$ 42.00 \$ 84.00	\$ 000.00
First Presentation of Multiple Dependent Claim(s)	(0)		\$140.00 \$280.00	\$ 000.00
Total				\$ 750.00

- If the difference is less than zero, enter "0".

21906 U.S. PTO
10/606057
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X Please charge Deposit Account No. 19-1457 in the amount of (\$ 790.00) to cover the filing fee (\$750.00) and assignment recording fee (\$40.00). A duplicate copy of this authorization is enclosed.

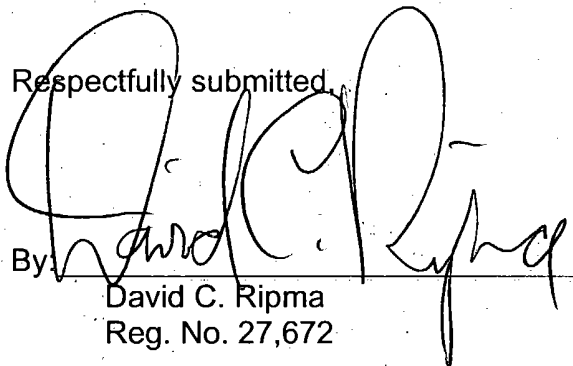
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X Any additional filing fees under 37 C.F.R. § 1.16.

X Any patent application processing fees under 37 C.F.R. § 1.17.

Date: 6/25/03

Respectfully submitted,

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	PATENT APPLICATION
)	
Inventors: Tingkai Li, Sheng Teng Hsu,)	
David R. Evans and Bruce D.)	
Ulrich)	
)	
Serial No.: Not Yet Assigned)	Attorney Docket No.
)	SLA 0673
Filed: Herewith)	
)	
Title: MOCVD SELECTIVE DEPOSITION OF C-AXIS ORIENTED)	
Pb ₅ Ge ₃ O ₁₁ THIN FILMS ON)	
HIGH-k GATE OXIDES)	
)	
Assignee: Sharp Laboratories of America,)	
Inc.)	
)	

**CERTIFICATE OF MAILING BY "EXPRESS MAIL"
UNDER 37 C.F.R. § 1.10**

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Signature Date: **June 25, 2003**

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Transmitted herewith for filing is a patent application identified as follows: